



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Toru TAKAYAMA et al.

Serial No. 10/650,046

Filed: August 28, 2003

For: MANUFACTURING METHOD FOR A
SEMICONDUCTOR DEVICE AND
HEAT TREATMENT METHOD
THEREFOR

) Group Art Unit: 2813

) Examiner: T. Nguyen

) CERTIFICATE OF MAILING

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) 2007.

) Adrian M. Stampler

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated July 20, 2007, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 12 of this paper.